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* Admitted only in Maryland
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* Practice Limited to
Federal Agencies

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Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Mail Stop Amendment

Re: U.S. Utility Patent Application
Application No. 10/602,069; Filed: June 24, 2003
For: **Optical System for Maskless Lithography (as currently amended)**
Inventors: Smirnov *et al.*
Our Ref: 1857.1870000

Sir:

Transmitted herewith for appropriate action are the following documents:

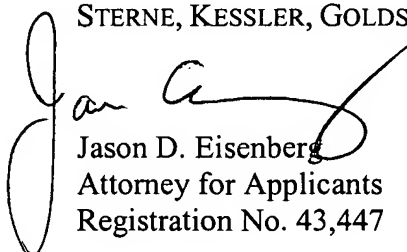
1. Amendment and Reply Under 37 C.F.R. § 1.111; and
2. One (1) return postcard.

It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Smirnov et al.

Appl. No.: 10/602,069

Filed: June 24, 2003

For: **Optical System for Maskless
Lithography** (as currently
amended)

Confirmation No.: 1221

Art Unit: 2851

Examiner: A. Mathews

Atty. Docket: 1857.1870000

Amendment and Reply Under 37 C.F.R. § 1.111

Commissioner for Patents
Mail Stop Non-Fee Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated **September 10, 2004**, Applicants submit the following Amendment and Reply.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefore (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.